# Relationships Between Impurity Gas and Luminance/Discharge **Characteristics of AC PDP**

Jeong-Eun Heo<sup>a</sup>, Sung-Hyun Lee<sup>a\*\*</sup>, Young-Kee Kim<sup>a\*\*</sup>, Jooh-Hong Shin<sup>b</sup>, Choong-Hee Yoob, and Chung-Hoo Parka\*

#### **Abstract**

The luminance and discharge characteristics of an AC PDP may be significantly affected by a small amount of impurity gas in working gas. Impurity gases such as O2, O, C and H2 can be mixed in the manufacturing and /or discharge processes. In this paper, a small amount of impurity gas in AC PDP are introduced intertimally and the relationship between the amount of impurity gas and the luminance/discharge characteristics are investigated. The luminous efficiency decreased seriously with the increase in the partial pressure of impurity gases, especially in H<sub>2</sub>, O<sub>2</sub> and CO<sub>2</sub>. Under the condition of the impurity gas ratio of 2× 10<sup>-3</sup> for Ar, N<sub>2</sub>, H<sub>2</sub>, CO<sub>2</sub> and O<sub>2</sub>, the luminous efficiency decreased to about 8 %, 8 %, 32 %, 36 % and 50 %, respectively.

Keywords: AC PDP, impurity gas, luminance/discharge characteristics

#### 1. Introduction

AC plasma display panel(PDP) is a flat panel display, which utilizes gas discharge. Fig. 1 shows the principle structure of a discharge cell in AC PDP. The size of a discharge cell is about 0.3 mm×1 mm×0.15 mm (height). The tri-primary colors(R, G, B) are obtained from RGB phosphors excited by vacuum ultraviolet photons emitted from gas discharge. AC PDP is now considered to be one of the most leading candidates for the large area wall hanging TVs.

It still has yet to be improved, however, in terms of cost, luminous efficiency and so on[1~15]. Especially,

one of the serious problems is the decrease of the luminance and luminous efficiency caused by contamination of the working gas.

The working gas in PDP should be chemically stable and should emit an large amount of UV(Ultra-Violet)[16]. In order to meet these conditions, He, Ne or Xe mixture gases are used at pressures between 300 and 500 Torr. If the impurity gases such as O2, O, CO2 and H<sub>2</sub> are included in working gas, they can increase the discharge voltage, contaminate the MgO layer and decrease the UV intensity, thus affecting the PDP's performance. The impurity gases are mainly generated from the manufacturing process and discharge process [17].

In this study, we investigated the effects of impurity gases on luminance, luminous efficiency and discharge characteristics in AC PDP after introducing impurity gases such as Ar, N<sub>2</sub>, O<sub>2</sub>, H<sub>2</sub> and CO<sub>2</sub>.

11, 2001.

Manuscript received May 21, 2001; accepted for publication December

This work was partially supported by Dong-eui University Research Fund and by PDP Research division (G-7 project) and LG Electronics Inc. in South Korea.

Member, KIDS; \*\*Student Member, KIDS.

Corresponding Author: Jeong-Eun Heo

E-mail: Indian heo@hanmail.net Tel: +51 510 1544

Fax: +51 513 0212

# 2. Experimental

Table 1 shows the specification of 4-inch test PDP

a. Department of Electrical Engineering, Pusan National University Mt. 30, Jang-jeon Dong, Keum-jeong Gu, Pusan, 609-735, Korea.

b. Department of Electrical Engineering, Dong Eui University, Pusan 614-714, Korea.

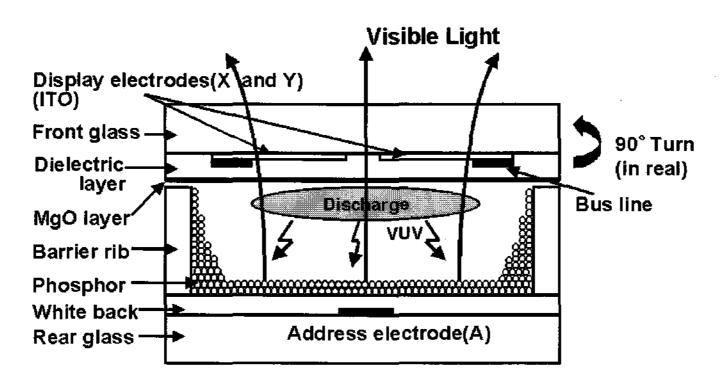


Fig. 1. Principal structure of a discharge cell in AC PDP.

Front panel		Rear panel	
ITO width	310 μm	Address electrode width	100 μm
ITO gap	60 μm	White back thickness	15 μm
Bus width	100 μm	Rib height	150 μm
Dielectric thickness	25 μm	Rib pitch	360 μm
MgO thickness	5000 Å	Rib width	70 μm
		Phosphor thickness	20 μm

**Table 1.** Specification of 4-inch AC PDP.

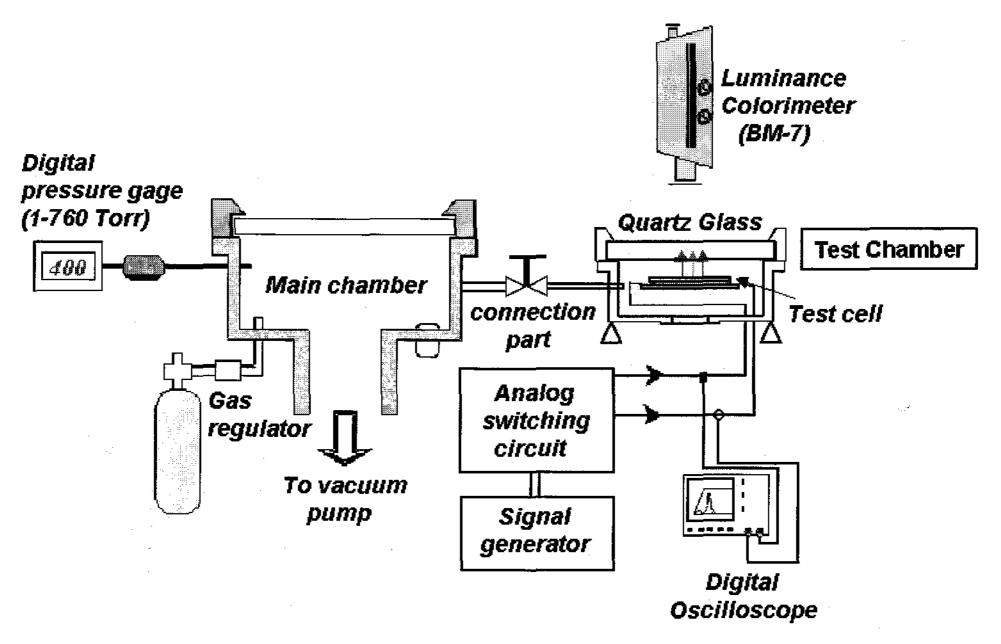


Fig. 2. The schematic diagram of test chamber for testing.

used in this study with VGA resolution.

Fig. 2 shows the schematic diagram of discharge test chamber and driving circuit for measuring the

electrical and optical characteristics of test panel. The test chamber is connected to the main chamber, which is a cylindrical type with the diameter of 200 mm and the

height of 80 mm with molecular pump vacuum system. The upper part of test chamber has a quartz window for investigating the optical characteristics.

The panel in the test chamber were baked in vacuum at  $350\,^{\circ}$ C for two hours, exhausted up to  $\sim 10^{-7}$  Torr by molecular pump, and then at a given impurity gas ratio and working gas(He+Ne 70 %+Xe 4 %) were injected. The ratio of impurity gas to the working gas were varied in the range of  $2\times 10^{-3}\sim 10\times 10^{-3}$ . After the test chamber was filled with discharge gas of 400 Torr, the firing voltage, sustaining voltage, luminance and discharge current waveform of the test panels are tested.

The applied ac pulse voltage was 210 V with 50 kHz and the duty ratio was 0.5.

The luminous efficiency was calculated using the following formula [17].

Luminous efficiency(lm/W)

$$= \frac{\pi \times \text{Lu} \min \text{ance}(\text{cd/m}^2) \times \text{Display Area}(\text{m}^2)}{\text{Power consumption}(\text{W})}$$
 (1)

Power consumption(W)

$$=2f\int_{0}^{T/2} v_{s}(t)(i_{on}(t)-i_{on}(t))dt$$
 (2)

Where, f is the frequency, T is the period,  $i_{on}$  is the total current and  $i_{off}$  is the displacement current.

### 3. Results and Discussions

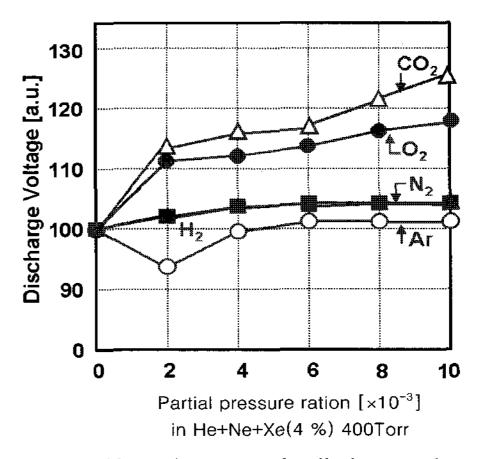
Fig. 3 shows the effect of impurity on the discharge voltage compared with that of the pure working gas, as a standard. As shown in Fig. 3, the discharge voltage increased significantly with the partial pressure of O<sub>2</sub> and CO<sub>2</sub> gases, whereas slightly with Ar, N<sub>2</sub> and H<sub>2</sub>. Especially the sudden decrease in the discharge voltage with Ar at 400 Torr may because to be due to the Penning effect with Ne gas[18].

Under the condition of the impurity gas ratio of  $2\times10^{-3}$ , the discharge voltage for the impurity gas of  $CO_2$ ,  $O_2$ ,  $N_2$ ,  $H_2$  and Ar increased to about 15 %, 12 %, 4 %, 2.5 % and -8 %, respectively.

The effect of impurity gases such as  $CO_2$  and  $O_2$  on the electrical and luminous characteristics of AC PDP

may come from the negative-ion formation by the electronegative gases[19]. It is well known that the negative ions formation gas suppresses the spark breakdown by forming negative ions. However, in the discharge plasma, CO<sub>2</sub> gas reacts with MgO, to form MgCO<sub>3</sub>, which is an irreversible reaction. Furthermore, the MgCO<sub>3</sub> has a low γ-coefficient than MgO. The highest discharge voltage of CO<sub>2</sub>, as shown in Fig. 3, may be due to the MgCO<sub>3</sub> on the MgO surface[20].

Fig. 4 shows the effect of impurity gases on the luminance. As shown in Fig. 4, the luminance decreased significantly with the increase in the impurity gases, especially in  $H_2$ ,  $O_2$  and  $CO_2$ . Under the condition of the impurity gas ratio of  $2\times10^{-3}$  for the Ar,  $N_2$ ,  $H_2$ ,  $CO_2$  and  $O_2$ , the luminance decreased to about 10 %, 10 %, 40 %, 45 % and 60 %, respectively.



**Fig. 3.** Effect of impurity gas on the discharge voltage of AC PDP.

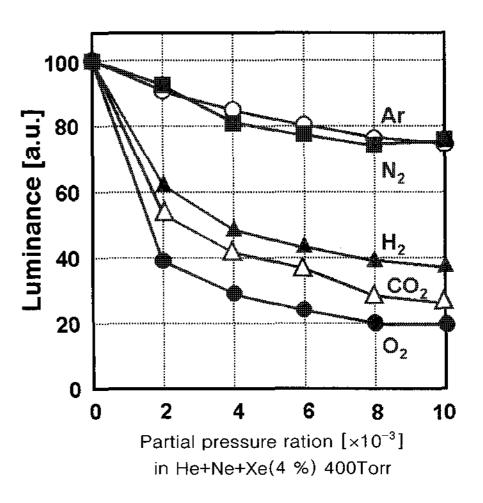
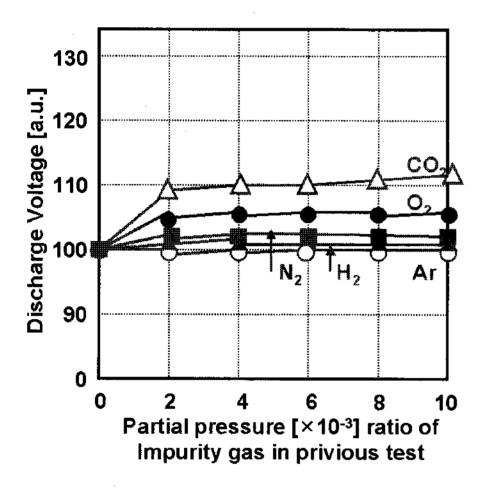


Fig. 4. Effect of impurity gas on the luminance of AC PDP.

Fig. 5 shows the effect of the given impurity gas on

the luminous efficiency, which are very similar to those shown in Fig. 4. With the presence of impurity gas ratio of  $2\times10^{-3}$  for the impurity gas of Ar, N<sub>2</sub>, H<sub>2</sub>, CO<sub>2</sub> and O<sub>2</sub>, the luminous efficiency decreased to about 8 %, 8 %, 32 %, 36 % and 50 %, respectively.

As mentioned above, the effect of impurity gas such as CO<sub>2</sub>, O<sub>2</sub>, and H<sub>2</sub> on the discharge voltage, luminance and luminous efficiency are very significant. Here, it may be worth pointing out whether the characteristics of discharge voltage and luminance of AC PDP is recovered or not when the contaminated gas was changed with a new working gas.



**Fig. 6.** Discharge inception voltage characteristics when the given contaminated gas is changed with new working gas after testing.

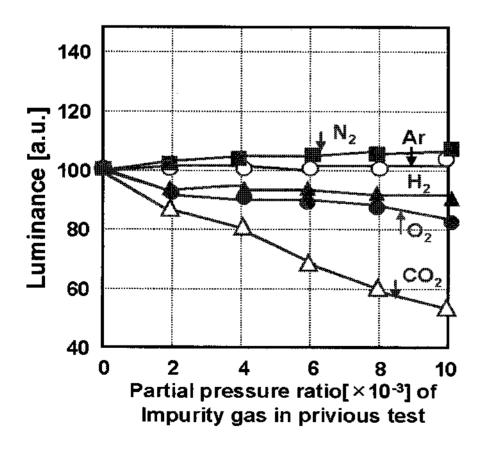


Fig. 7. Luminance characteristics when the given contaminated gas is changed with new working gas after testing.

Figs. 6 and 7 show the discharge voltage and luminance characteristics when the contaminated working gas is degassed and refilled with a new working gas

of He+Ne 70 %+Xe 4 % with 400 Torr.

As shown in Figs. 6 and 7, the discharge voltage and luminance characteristics with  $N_2$ , Ar and  $H_2$  are almost recovered, whereas those with  $O_2$  and  $CO_2$  are not. The reasons may be due to the following assumptions.

As mentioned in Fig.3, the CO<sub>2</sub> gas makes MgCO<sub>3</sub> on the MgO. Furthermore, this reaction is irreversible [20]. Therefore, the discharge and luminance characteristics are not recovered.

Especially,  $O_2$  gas also degasses mostly with other impurity gasses. However, the  $O_2$ , or O gas from the dissociation of  $O_2$  gas in the discharge plasma have high electron affinity coefficient as shown in Table 2. Therefore, the small amount of  $O_2$  gas affects signifycantly influences the discharge voltage and luminance characteristics.

**Table 2.** Electron affinity of some important gases.

Kind of atom or molecule	Electron affinity [eV]	
F	3.94	
В	3.70	
Br	3.54	
Ι	3.22	
О	3.80	
$O_2$	~1.0	
Н	0.75	
$H_2$	0.76	
N	~0.04	
$N_2$	0.04	
Inert gases	<b>≒</b> 0	

# 4. Conclusion

In this paper, a small amount of impurity gas in AC PDP was introduced quantitatively and the relationship between the amount of impurity gas and the luminance/discharge characteristics were investigated.

The luminous efficiency decreased seriously with increase in the partial pressure of impurity gases, especially in  $H_2$ ,  $O_2$  and  $CO_2$ . With the addition of the impurity gas ratio of  $2\times10^{-3}$  for Ar,  $N_2$ ,  $H_2$ ,  $CO_2$  and  $O_2$ , the luminous efficiency decreased to about 8 %, 8 %, 32 %, 36 % and 50 %, respectively.

It is considered that the impurity gas, effect on PDP characteristics result from the negative- ion formation in the case of O<sub>2</sub> and H<sub>2</sub>, and irreversible MgCO<sub>3</sub> formation on the MgO surface in the case of CO<sub>2</sub>.

#### References

- [1] S. Yoshikawa, "Full-color AC plasma display with 256 gray scale," Japan Display, pp. 605-608, 1992.
- [2] A. Sobel, "Big, Bright, and Beautiful," Information Display (SID), vol. 14, no. 9, pp. 26-28, 1998.
- [3] Chung-Hoo Park, Sung-Hyun Lee, Dong-Hyun Kim, Woo-Geun Lee and Jeong-Eun Heo "Improvement of Addressing Time and its Dispersion in AC Plasma Display Panel", IEEE Transactions on Electron Devices, vol. 48, no. 10, 2001.
- [4] Woo-Geun Lee, Jae-Young Lee, Jae-Moon Park, Chung-Hoo Park, "An Electrical and Optical Characteristics of the Color ac Plasma Displays with a New Cell Structure", Journal of Information Display, vol. 2, no. 1, pp. 5-9, march. 2001.
- [5] Jeong-Eun Heo, Young-Kee Kim, Hun-Gun Park and Chung-Hoo Park, "The Optimum Phosphor Thickness to Obtain the Highest Luminance and Luminous Efficiency in ac PDP," Journal of Information Display, vol. 2, no. 1, pp. 14-19, March. 2001
- [6] Sung-Hyun Lee, Young-Dae Kim, Joong-Hong Shin, Jung-Soo Cho and Chung-Hoo Park, "The Effect of Dielectric Thickness and Barrier Rib Height on Addressing Time of Coplanar ac PDP," Journal of KIEE, vol. 11, no. 1, pp. 41-45, march, 2001.
- [7] Jeong-Eun Heo, Young-Kee Kim, Min-Nyoung Hur, Yun-Gi Kim, Ho-Jun Lee and Chung-Hoo Park, "The Relationship between a small amount of Impurity gas and Luminance/Discharge Characteristics of AC PDP," Proceedings of the 1st IMID, pp. 126-129, August, 2001.
- [8] Sung-Hyun Lee, Dong-Hyun Kim, Woo-Geun Lee, Cha-Soo park, Jae-Hwa Ryu and Chung-Hoo Park, "A New Driving Scheme for Reduction of Addressing time and its Dispersion in AC PDP," Journal of Information Display, vol. 2, no. 2, pp. 39-44, June. 2001.
- [9] Chung-Hoo Park, Young-Kee Kim, Sung-Hyun Lee. Woo-Geun Lee and Youl-Moon Sung, "Surface-discharge characteristics of MgO-thin films prepared by reactive RF unbalancend maganetron sputtering," Thin Solid

- Films, vol. 366, pp. 88-94, march. 2000.
- [10] Jeong-Eun Heo, Gi-Bum Lee, Young-Seup Moon, Min-Nyoung Hur, Gyu Seup Kim, Jung-Soo Cho and Chung-Hoo Park, "A Characteristics of Luminance Efficiency by Barrier Rib Height and Phosphor Thickness in AC PDP," Proc. 2000. K. J Joint Symposium on EDHV Engineering, pp. 405-1~405-4, 2000.
- [11] Sung-Hyun Lee, Young-Dae Kim, Young-Seup Mun, Jae-Bong Shon, Jae-hwa Ryu, Chung-Hoo Park and Jung-Soo Cho, "A New Method to Reduce Addressing Time of ADS Method for AC PDP," Proc. IDW'00, pp. 2000.
- [ 12 ] Dong-Hyun Kim, Sung-Htun Lee, Young-Dae Kim, Jung-Tae Park, Gi-Bum Lee, Jae -Young Lee, Jae-Hwa Ryu and Chung-Hoo Park, "Wall Charge Measurement in the Address Period of AC Plasma Display Panel," Journal of Information Display, vol. 1, no. 1, December, 2000.
- [ 13 ] Woo-Geun Lee, Jae-Young Lee, Jae-Moon Park and Chung-Hoo Park, "An Electrical and Optical Characteristics of the Color ac Plasma Displays with a New Cell Structure," Journal of Information Display, vol. 2, no. 1, March 2000.
- [ 14 ] Dong-Hyun Kim, Sung-Hyun Lee, Young-Dae Kim, Jung-Tae Park, Gi-Bum Lee, Jae-Young Lee, Chun-Hoo Park and Jae-Hwa Ryu, "Wall Charge measurement in the Address Period of AC Plasma Display Panel," Journal of Information Display, vol. 1, no. 1, December, 2000.
- [15] Chung-Hoo Park, Dong-Hyun Kim, Sung-Hyun Lee, Jae-Hwa Ryu and Jung-Soo Cho, "A New Method to Reduce Addressing Time in a large AC Plasma Display Panel," IEEE Transactions on Electron Devices, 2000.
- [ 16 ] Bernard W. Byrum, "Surface Aging mechanisms of AC Plasma Display Panels," IEEE Trans. On Electron Devices, vol. ED-22, no. 9, pp. 685-691, 19751.
- [17] Jae-Young Lee, Young-Kee Kim, Young-Dae Kim, Yun-Gi Kim, Je-Bong Sohn, Cha-Soo Park and Chung-Hoo Park, "A Study on the New Shaped Align Free Sustain Electrode Showing High Luminous Efficiency in AC PDPs," Proc. 2000. K. J Joint Symposium on EDHV Engineering, pp. 804-1~804-4, 2000.
- [ 18 ] M. O. Aboelfotoh, "Aging Characteristics of AC Plasma Display Panel," Proc. SID vol. 22/4, pp. 219-227, 1981.
- [ 19 ] E. Nasser, "Fundamentals of Gaseous Ionization & Plasma Electronics", Wiley Inter Science, pp. 214-217, 1971.
- [20] 安臟 久人夫, "最新プラズマディスプレイ製造技術," タカノ株式會社, p. 113, 1985.